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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Kanshi CHINONE**

Art Unit: **1793**

Application Number: **10/568,147**

Examiner: **Michael A. MARCHESCHI**

Filed: **February 13, 2006**

Confirmation Number: **7793**

For: **ABRASIVE COMPOUNDS FOR SEMICONDUCTOR PLANARIZATION**

Attorney Docket Number: **062110**
Customer Number: **38834**

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. §1.97(b)

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

April 8, 2009

Sir:

In compliance with 37 C.F.R. §1.56, Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. This paper is being filed within the time periods set forth in 37 C.F.R. §1.97(b). A copy of each non-U.S. document is enclosed herewith.

This IDS is submitted in further compliance with the concise explanation requirement under 37 C.F.R. § 1.98(a)(3) for foreign language documents. Applicant encloses herewith a copy of a Communication from a foreign patent office in a counterpart application citing previously submitted JP10-154673, together with an English-language version of at least that portion of the Communication indicating the degree of relevance found by the foreign patent office.

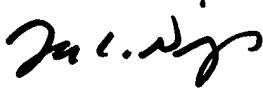
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If there are any fees due in connection with the filing of this paper, please charge Deposit
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Respectfully submitted,

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Enclosures: PTO/SB/08
Documents